

JFW

Appl. No. 10/810,209
Amdt. dated 1/05/2006

PATENT

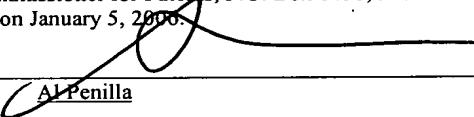


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:)
GOTKIS) Group Art Unit: 1765
Application No: 10/810,209) Examiner: Anita Karen Alanko
Filed: March 26, 2004) Atty. Docket No: LAM2P466
For: METHOD AND APPARATUS FOR) Date: January 5, 2006
MEASUREMENT OF THIN FILMS AND)
RESIDUES ON SEMICONDUCTOR)
SUBSTRATES)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 5, 2006.

Signed: 
AI Penilla

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

This Amendment is submitted in response to the Office Action dated October 5, 2005, within the three-month period for reply extending to January 5, 2005. Please enter the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Amendment.

Remarks/Arguments begin on page 6 of this Amendment.